Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/767,767	OGAWA, HIDEHIKO	
Examiner	Art Unit	
Thomas D. Lee	2624	

	SEAR	CHED	
Class	Subclass	Date	Examiner
358	1.15, 402, 440	11/22/2005	TDL
379	100.01	11/22/2005	TDL
379	100.08	11/22/2005	TDL
379	100.13	11/22/2005	TDL
379	100.17	11/22/2005	TDL
			-

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		